

Sheet 1 of 1

US Patent & Trademark Office 1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 116523		APPLICATION NO. 10/719,210	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)							
APPLICANT(S) Richard M. WASSERMAN et al.							
FILING DATE November 24, 2003							
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	1	QVPAK 3D CNC Vision Measuring Machine Users Guide, published January 2003.					
	2	QVPAK 3D CNC Vision Measuring Machine Operation Guide, published September 1996.					
EXAMINER <u>Le</u>				DATE CONSIDERED <u>10/05</u>			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: December 17, 2003

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 116523		APPLICATION NO. New US Application	
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U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	1	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
1	1	5,790,710	08/04/1998	Price et al.	<del>          </del>	<del>          </del>	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
1	2	"High Speed, Real-Time Machine Vision", Perry West- Automated Vision Systems, Inc., pp 1-38, 2001					
1	3	Jan-Mark Geusebroek et al, "Robust Autofocusing in Microscopy", ISIS technical report series, Vol. 17, November 2000, pp 1-16					
EXAMINER  <span style="font-size: 1.5em;">Le</span>				DATE CONSIDERED <span style="font-size: 1.5em;">10/05</span>			
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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
1		2003/0197925 A1	10-23-2003	Hamborg			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
1		EP 1 381 229 A1	01-14-2004	Europe			
1		WO 00/75709 A1	12-14-2000	WIPO			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER  Le				DATE CONSIDERED 10/05			
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Date: April 13, 2005